

Title (en)
COATED CONDUCTOR THICK FILM PRECURSOR

Title (de)
BESCHICHTETE LEITER DICKSCHICHTVORSTUFE

Title (fr)
PRECURSEUR DE FILM EPAIS A CONDUCTEUR REVETU

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Abstract (en)
[origin: WO0108236A1] Methods for preparing thick film rare-earth Ba₂<Cu>3<O>7- delta < (such as YBCO) superconductive layers, particularly including deposition of a precursor as a dispersion of solid-state materials, including a binder or a solvent or both constituents. The solid-state materials include oxides, fluorides, and acetates of yttrium, barium, and copper in the form of ultrafine particles.

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H01L 39/24

IPC 8 full level
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